

## Electronic Patent Application Fee Transmittal

Application Number:	10813390
Filing Date:	31-Mar-2004
Title of Invention:	System and method of removing chamber residues from a plasma processing system in a dry cleaning process
First Named Inventor/Applicant Name:	Marcel Gaudet
Filer:	Marvin Jay Spivak/Sachie Fazzone
Attorney Docket Number:	250312US6 YA

Filed as Large Entity

### **Utility Filing Fees**

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
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**Basic Filing:**

**Pages:**

**Claims:**

**Miscellaneous-Filing:**

**Petition:**

**Patent-Appeals-and-Interference:**

Notice of appeal	1401	1	510	510
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Post-Allowance-and-Post-Issuance:

**Extension-of-Time:**

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Extension - 1 month with \$0 paid	1251	1	120	120
<b>Miscellaneous:</b>				
<b>Total in USD (\$)</b>				<b>630</b>